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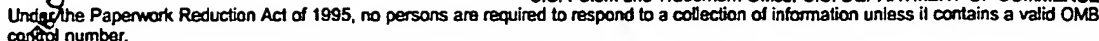
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1 Applicant's unique citation designation number (optional). <sup>2</sup> See Kinds Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov) or MPEP 901.04. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.

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Substitute for form 1449B/PTO <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> <i>(use as many sheets as necessary)</i>			<b>Complete if Known</b>		
			Application Number	10/077.915	
			Filing Date	02/19/2002	
			First Named Inventor	Patrick R. Connelly	
			Group Art Unit	3762	
			Examiner Name		
			Attorney Docket Number	BTI-5	
Sheet	3	of	3		

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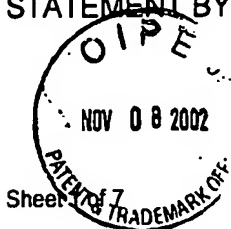
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INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT



Application Number 10/077,915  
Filing Date February 19, 2002  
First Named Inventor Jeffrey Helfer  
Art Unit 3762  
Examiner Name  
Attorney Docket Number BTI-5

US PATENT DOCUMENTS

Examiner Initials	Cite No.	Document No.	Publication Date	Name of Patentee or Applicant of Cited Documents
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Sheet 2 of 2

Application Number 10/077,915  
Filing Date February 19, 2002  
First Named Inventor Jeffrey Helfer  
Art Unit 3762  
Examiner Name  
Attorney Docket Number BTI-5

US PATENT DOCUMENTS

Examiner Initials	Cite No.	Document No.	Publication Date	Name of Patentee or Applicant of Cited Documents
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Sheet 3 of 7

Application Number 10/077,915  
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First Named Inventor Jeffrey Helfer  
Art Unit 3762  
Examiner Name  
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US PATENT DOCUMENTS

Examiner Initials	Cite No.	Document No.	Publication Date	Name of Patentee or Applicant of Cited Documents
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Sheet 4 of 7

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First Named Inventor Jeffrey Helfer  
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Examiner Name  
Attorney Docket Number BTI-5

US PATENT DOCUMENTS

Examiner Initials	Cite No.	Document No.	Publication Date	Name of Patentee or Applicant of Cited Documents
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Sheet 5 of 7

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Sheet 6 of 7

US PATENT DOCUMENTS

Examiner Initials	Cite No.	Document No.	Publication Date	Name of Patentee or Applicant of Cited Documents
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Sheet 7 of 7

US PATENT DOCUMENTS

Examiner Initials	Cite No.	Document No.	Publication Date	Name of Patentee or Applicant of Cited Documents
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Foreign Patent Documents				
Examiner Initials	Cite No.	Foreign Patent Document	Publication Date	Name of Patentee or Applicant of Cited Document
SG	241	WO0174241	10-11-2001	Surgi-Vision

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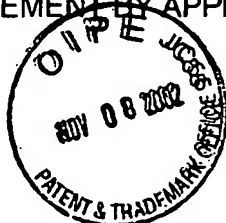
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Sheet 1 of 3 of Other Prior Art

Examiner Initials	Cite	Other Prior Art Non Patent Literature Documents
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INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT



Application Number 10/077,915  
Filing Date February 19, 2002  
First Named Inventor Jeffrey Helfer  
Group Art Unit 3762  
Examiner Name  
Docket BTI-5

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